



Sheet 1 of 3

PTO-1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 207.010-US	SERIAL NUMBER 10/698,258
	APPLICANT(S) Lutz et al.	
	FILING DATE October 31, 2003	GROUP ART UNIT 2814

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
Dh	2002/0132062	9/2002	Jacobs			
	2002/0179126	12/2002	DeYoung et al.			
	2002/0197002	12/2002	Lin			
	2003/0002019	1/2003	Miller			
	2003/0016337	1/2003	Duncan et al.			
	2003/0038327	2/2003	Smith			
	2003/0054588	3/2003	Patel et al.			
	2003/0146464	8/2003	Prophet			
	2003/0155643	8/2003	Freidhoff			
	2003/0161949	8/2003	Ashurst et al.			
	2003/0178635	9/2003	Volant et al.			
	2003/0183916	10/2003	Heck et al.			
	6,492,309	12/2002	Behr et al.			
Dh	6,500,348	12/2002	Chase et al.			

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER Dh	DATE CONSIDERED Feb - 05
EXAMINER: Initial citation if reference was considered. Draw line through citation if not in conformance to MPEP 609 and not considered. Include copy of this form with next communication to applicant.	

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EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
<i>Dh</i>	6,590,267	7/2003	Goodwin-Johansson et al.			
	6,602,351	8/2003	DeYoung et al.			
	6,621,392	9/2003	Volant et al.			
	6,625,047	9/2003	Coleman, Jr.			
	6,625,342	9/2003	Staple et al.			
	6,318,175	11/2001	Muchow et al.			
	5,922,212	7/1999	Kano et al.			
	5,683,591	11/1997	Offenberg			
	5,804,083	9/1998	Ishii et al.			
<i>Dh</i>	6,423,563	7/2002	Fukada et al.			

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<i>Dh</i>	4,849,071	7/1989	Evans et al.			
	4,945,769	8/1990	Sidner et al.			
	5,445,991	8/1995	Lee			
	5,470,797	11/1995	Mastrangelo			
	5,616,514	4/1997	Muchow et al.			
<i>Dh</i>	6,521,508	2/2003	Cheong et al.			

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## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>Dh</i>	"Chemical Vapor Deposition of Fluoroalkylsilane Monolayer Films for Adhesion Control in Microelectromechanical Systems", Mayer et al., J. Vac. Sci. Technol. B 18(5), Sep/Oct 2000, pp.2433-2440

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